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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

NISHIUCHI et al.

Serial Number: 09/901,044

Group Art Unit: 3723

Filed: July 10, 2001

Examiner: E. P. Morgan

For: **DRY SURFACE TREATING APPARATUS AND DRY SURFACE TREATING
METHOD USING THE SAME APPARATUS**

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

June 17, 2002

Sir:

In response to the Office Action dated March 21, 2002, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Please replace the paragraph beginning at page 9, line 21, with the following rewritten paragraph:

Fig. 4A is a diagrammatic front view of an interior of a vacuum-treating chamber in a use example as a deposition apparatus and Figs. 4B and 4C show alternate shapes of a tubular barrel;

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